

## Supplementary Information

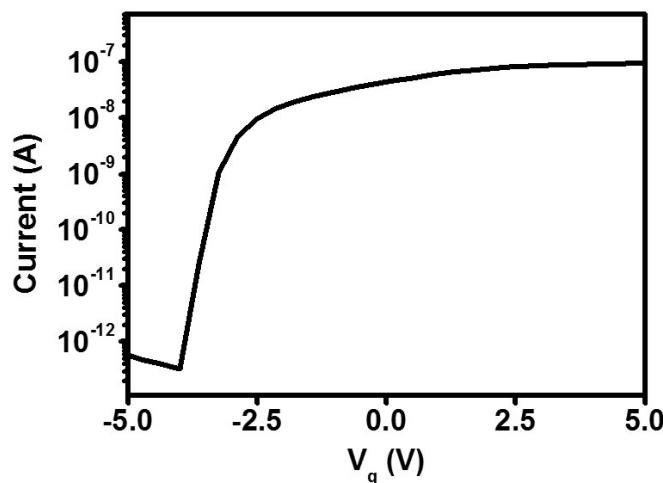
### Quantifying the barrier lowering of ZnO Schottky nanodevices under UV light

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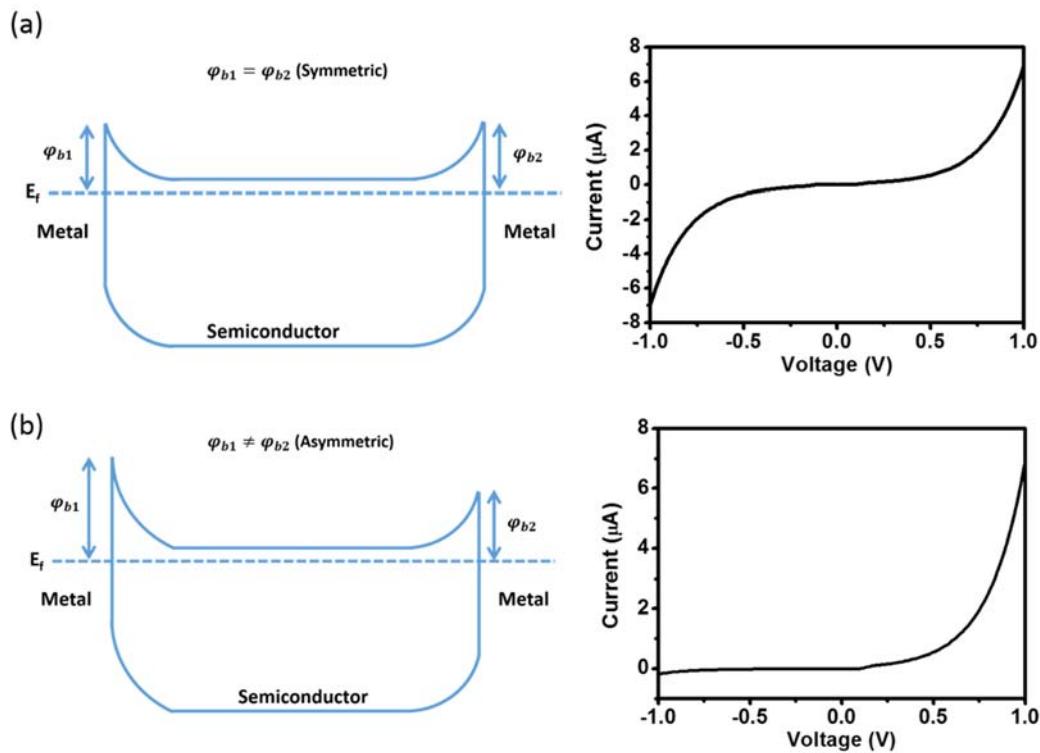
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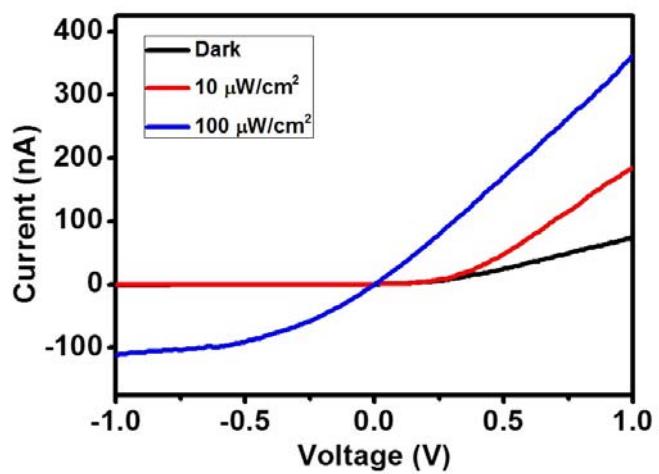
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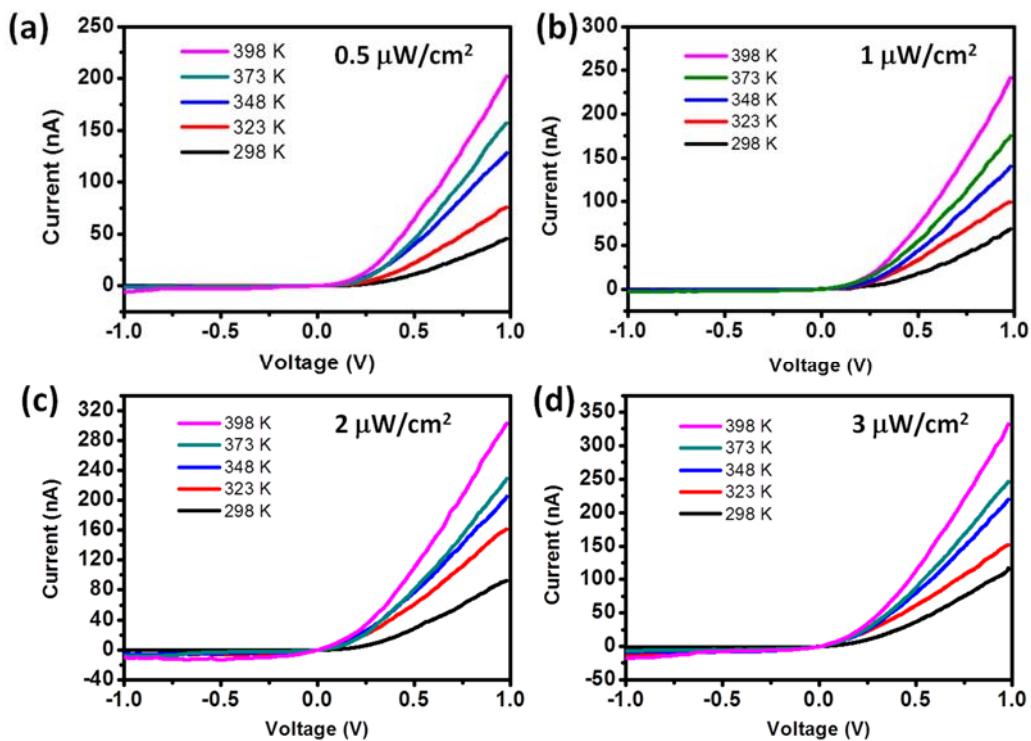
**Figure S1.**  $I_d$ - $V_g$  curve of ZnO NW ohmic device recorded at a value of  $V_d$  of 1V



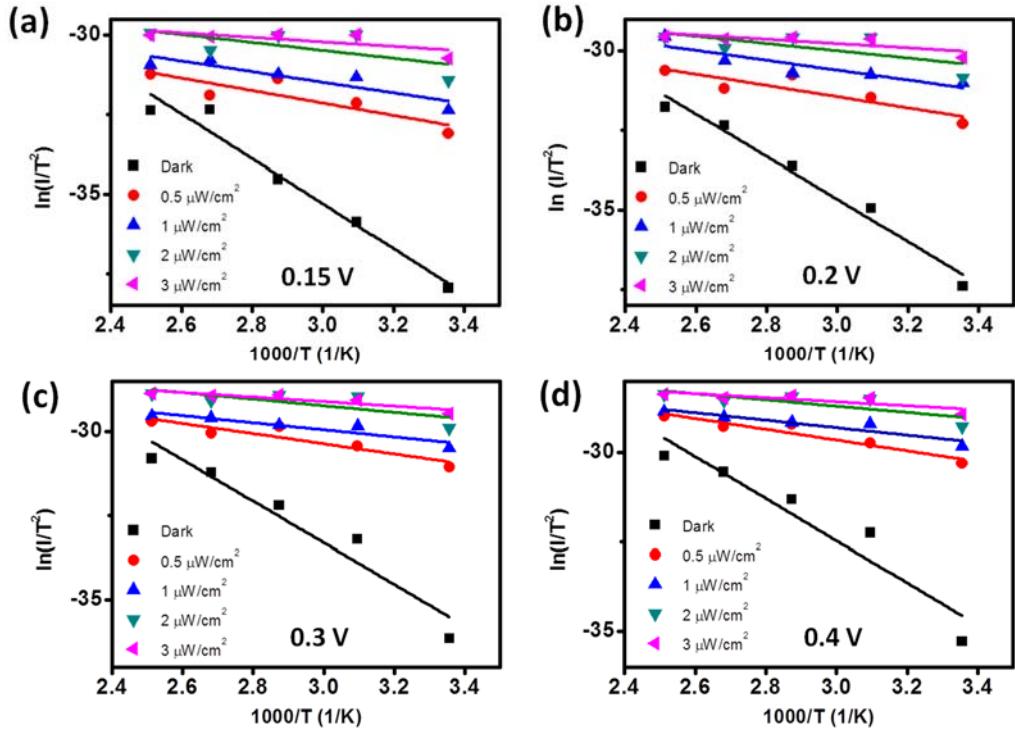
**Figure S2.** The band diagrams of the back-to-back Schottky device with (a) the same SBHs and (b) uneven SBHs. The corresponding simulated I-V curves are symmetric and asymmetric, respectively.



**Figure S3.** I-V curves of ZnO NW Schottky device at dark state and under 10 and 100  $\mu\text{W}/\text{cm}^2$  UV light illuminations.



**Figure S4.**  $I$ – $V$  curves of the Schottky device measured at temperatures ranging from 298 to 398 K under different UV illumination power density, (a)  $0.5 \mu\text{W}/\text{cm}^2$ , (b)  $1 \mu\text{W}/\text{cm}^2$ , (c)  $2 \mu\text{W}/\text{cm}^2$ , and (d)  $3 \mu\text{W}/\text{cm}^2$ .



**Figure S5.** Plots of  $\ln(I/T^2)$  versus  $1000/T$  of devices measured under different UV illuminated power density, the data are extracted from Fig. S1 at (a)  $V = 0.15 \text{ V}$ , (b)  $V=0.2 \text{ V}$ , (c)  $V=0.3 \text{ V}$ , and (d)  $V=0.4 \text{ V}$ .